



## High Rate Electrochromic Coatings (EC): DE-EE0003838

DOE Windows Roadmap Meeting, Minneapolis, MN, USA  
06/28/2012

### Team:

**Applied Materials CTO-Advanced Technologies Group  
& Lawrence Berkeley National Laboratory**

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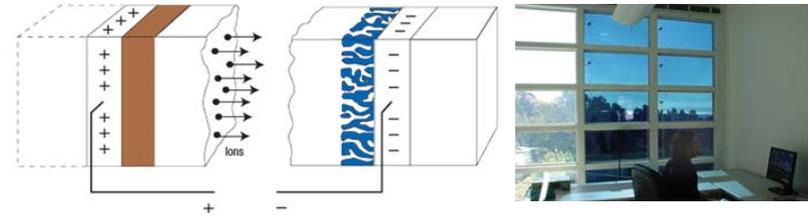
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# EC Program: Background, Purpose & Objectives

## ■ Background:

– Market application of EC windows are limited by

- Low value proposition (performance/cost)
- High manufacturing cost
- Insufficient advantage in energy savings vs. high efficiency low-e glasses



## ■ Project Purpose:

– Improve this value proposition by developing novel HVM technologies and methods to reduce cost.

## ■ Objectives:

- Concept and Feasibility (C&F) demonstration of Novel HVM equipment technologies;
- Develop fundamental models and methods to simulate EC devices
- C&F demonstration of laser based patterning methods (amended objective)

**“C&F to Scaling” is demonstrated core strength of Applied Materials**

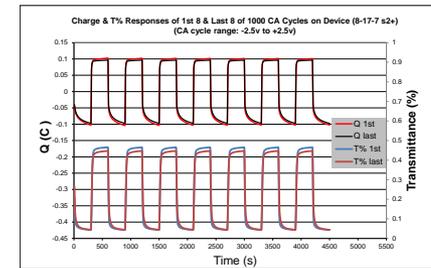
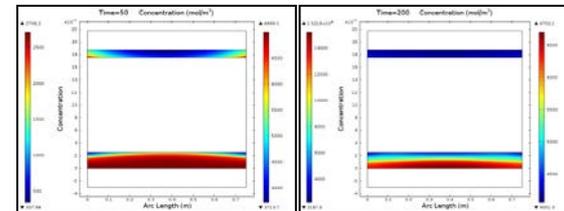
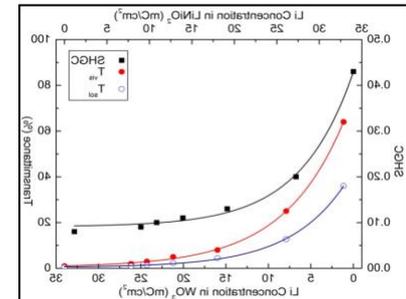
# Scope of Work and Cost Breakdown

- Scope of work
  - C&F demo of cost reducing HVM equipment technology
    - Novel deposition technologies for higher throughput manufacturing
      - Dielectric oxide deposition: Multiple Frequency Sputtering
      - Li deposition: linear deposition source
  - Development of fundamental device models and methods
    - Optical, electrical and electrochemical characteristics
  - C&F demo of laser based device fabrication methods
    - Laser/process selection based on optical/thermal properties
    - Fabricate using blanket depositions and laser
- Total cost of project (government and private shares)

	Cost Share	Gov. Share	Total
Applied	2,000,000	1,600,000	3,600,000
LBNL	0	400,000	400,000
Total			4,000,000

# Accomplishments to Date

- Dielectric oxide deposition: Multiple Frequency Sputtering
  - Hardware **completed**
  - Higher deposition rate (> 45% higher at same power) and better layer quality (higher ionic conductivity, smoother & fewer pinholes in thinner film) **demonstrated**
- Li deposition: linear deposition sources
  - Hardware **completed** for 1<sup>st</sup> concept; Larger linear source **designed**
- Device models and simulation methods
  - Fundamental model and simulation methods **completed**
    - 2 $\mu$ m thick device with lateral dimension up to 1m long (for electrical)
  - Validation of the models and simulation methods **completed**.
- Functional devices and flow **completed**
  - Cycled (continuing) to 1000 cycles with minimal changes
- Laser based device fabrication methods
  - Layer properties characterization **completed**



# Additional Accomplishments

## ■ Conference Presentations

- Spring Meeting, MRS 2011: Nuclear Reaction Analysis (NRA) of Li
- 9<sup>th</sup> International Conference on Coated Glasses (June 2012): Optical modeling and simulation of Electrochromic devices (accepted for oral presentation)
- International Meeting on Electrochromics 10: Electrical and optical modeling of Electrochromic devices (Planned - 2012)

## ■ Journal Publications

- Optical Modeling work: *Solar Energy Materials & Solar Cells* (submitted)
- Electrical Modeling work: *Journal of Electrochemical Society* (submitted)

## ■ Patent Applications

- Deposition methods for dielectric/ceramic materials
- Novel Li deposition sources
- Novel integration schemes and methods using laser based technologies
- New materials for device performance improvement

# Expected Outcome and Next Steps

## ▪ Expected Outcomes

- Novel HVM technology will improve the EC value proposition by lowering the cost and increasing the manufacturing energy efficiency
  - Higher CapEx efficiency (factory capacity and throughput per CapEx \$)
  - Simple creation of broader product portfolio
    - Multiple devices from single large substrate (by laser patterning) as in the Display industry
- Fundamental Device Model will help industry create better EC devices
  - Optimization of device structure and performance with existing materials data
  - Optimization of materials & device structure etc. to meet desired device performance specification

## ▪ Next steps

- Complete the remaining few tasks of the program
- Determine market viability of the resulting EC window technology
- Seek vertically integrated consortium in the window manufacturing chain to collectively address the emerging market



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into industries.™



Supplemental / For Reference

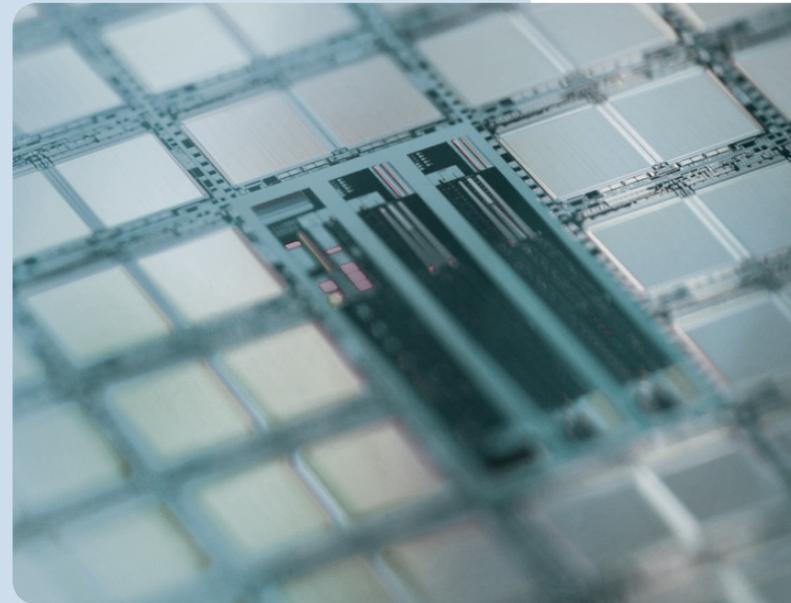
Applied Materials® Corporate Overview

# Turning Innovations into Industries™

**B. Leo Kwak, Ph.D.**

Distinguished Member of Technical Staff  
Corporate CTO Office, Applied Materials

June 4, 2012



## VISION

We apply  
nanomanufacturing  
technology to improve  
the way people live.



## WHAT WE DO

We make the **equipment** that makes the components that change the world.



# The Global Strength of Applied



<b>Stock Ticker:</b>	<b>Nasdaq: AMAT</b>
<b>Market Cap:</b>	<b>\$16.8 billion</b>
<b>Fiscal 2011 Revenue:</b>	<b>\$10.5 billion</b>
<b>Fiscal 2011 R&amp;D:</b>	<b>\$1.1 billion</b>
<b>Founded:</b>	<b>November 10, 1967</b>
<b>Headquarters:</b>	<b>Santa Clara, California</b>
<b>Global Presence:</b>	<b>87 locations in 19 countries</b>
<b>Fortune 500 Ranking:</b>	<b>259</b>

<b>RD&amp;E and/or Manufacturing Centers:</b>	<b>China, Germany, Israel, Italy, Singapore, Switzerland, Taiwan, United States</b>
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<b>Employees:</b>	<b>~14,600 worldwide</b>
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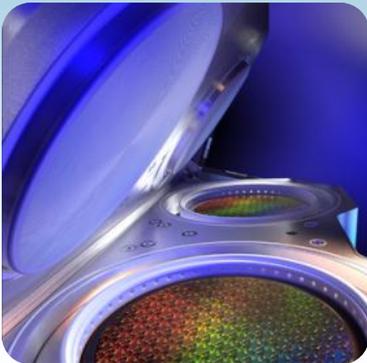
<b>Patents:</b>	<b>~9,500 issued</b>
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\* Information as of Q1'12 except FY'11 amounts  
Fiscal year-end October 30, 2011

# Business Segments



Semiconductor



Display



Energy and  
Environmental  
Solutions

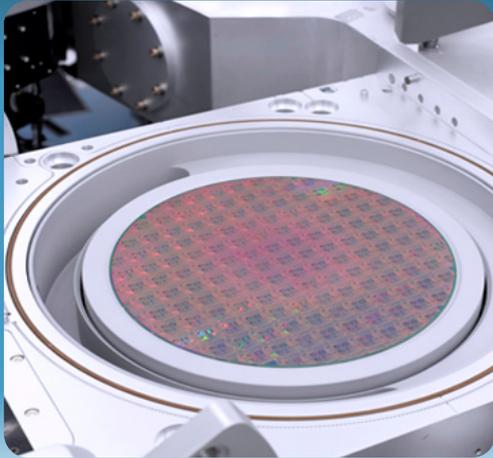


Applied Global  
Services



# The Most Exciting Industries on Earth

## Semiconductor



**20,000,000x**

reduction in  
COST PER TRANSISTOR  
in 30 years<sup>1</sup>

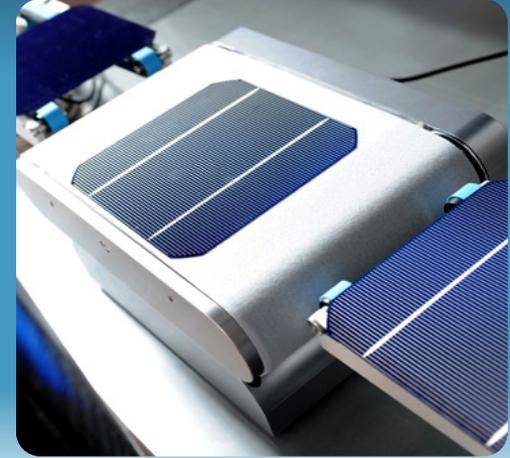
## Display



**20x**

reduction in  
COST PER AREA  
in 15 years<sup>2</sup>

## Solar



**5x**

reduction in  
COST PER WATT  
in 4 years<sup>3</sup>



At 1976 transistor prices,  
an iPod® would have cost \$3.2B

1 Source: SIA, IC Knowledge LLC

2 Source: Display Search, Nikkei BP, Applied Materials

3 Source: Photon Consulting 2012

# Enabling and Accelerating Innovation

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Thin film engineering

Commercializing sophisticated systems

Global reach

